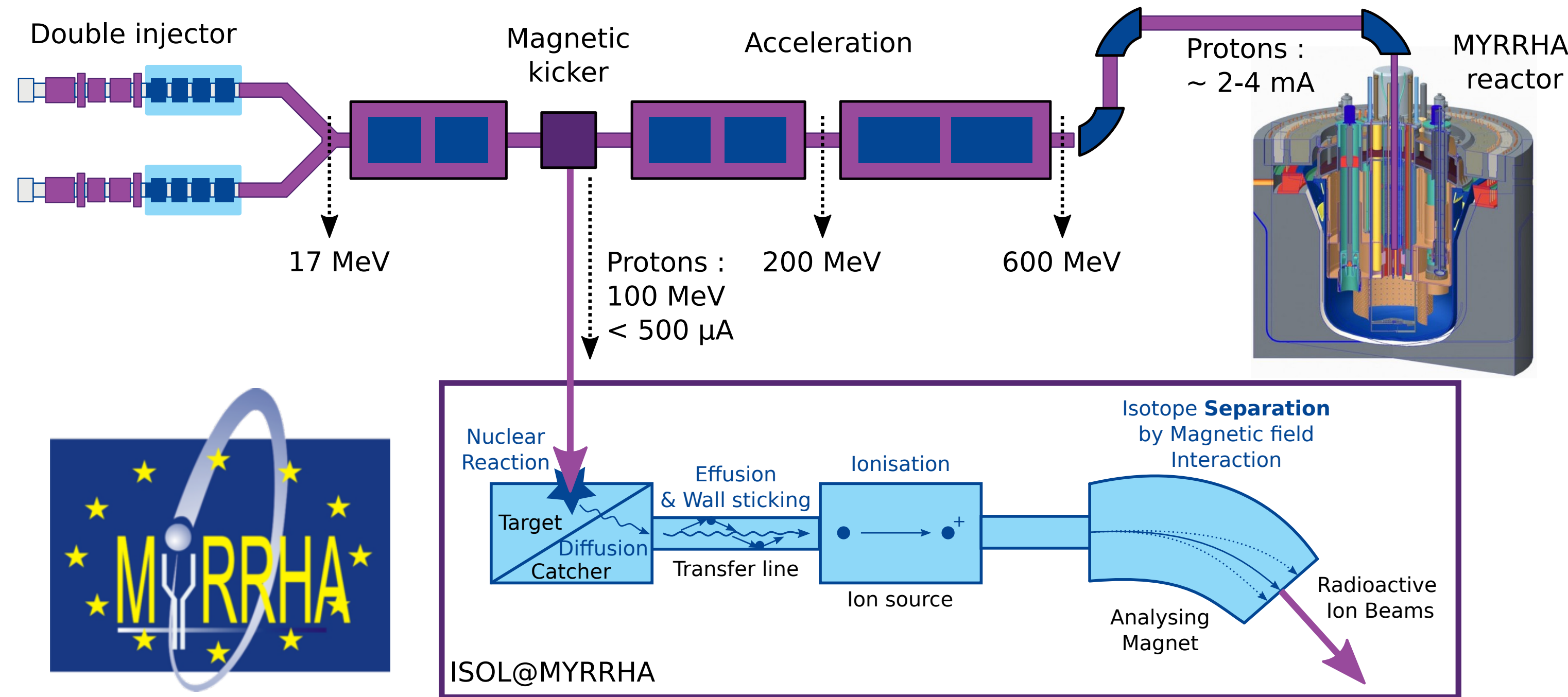


Introduction to ISOL@MYRRHA

MYRRHA: Multi-purpose hYbrid Research Reactor for High-tech Applications
 World's first large-scale **Accelerator Driven System** project at power levels scalable to industrial systems



ISOL@MYRRHA: will extract part of the proton beam coming from the accelerator and use it to produce Radioactive Ion Beams (RIBs) with the Isotope Separation On-Line (ISOL) technique.

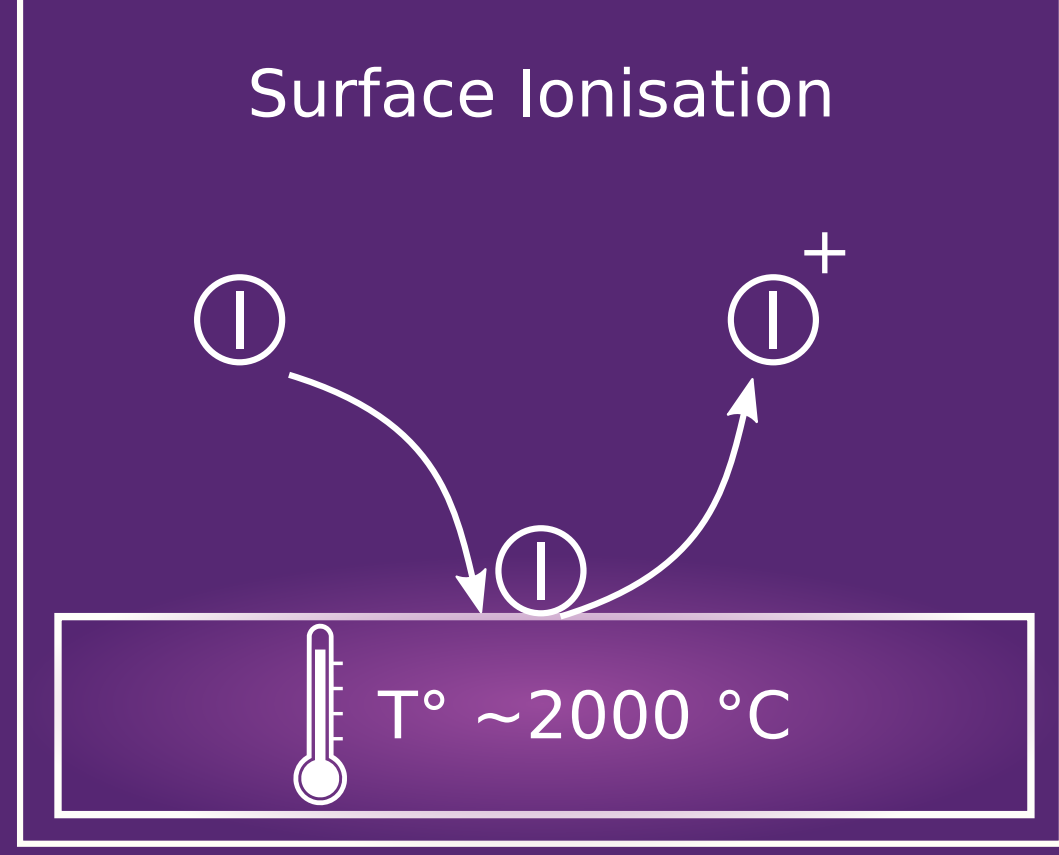
Increase the isotope production by:

- Using high intensity primary beams
- For a longer period of time
- Maintain the radioactive ion beam quality

Objectives

Surface Ion Source: reliable & simple design

When an isotope interacts with a heated surface, it can lose or gain an electron before leaving the surface.

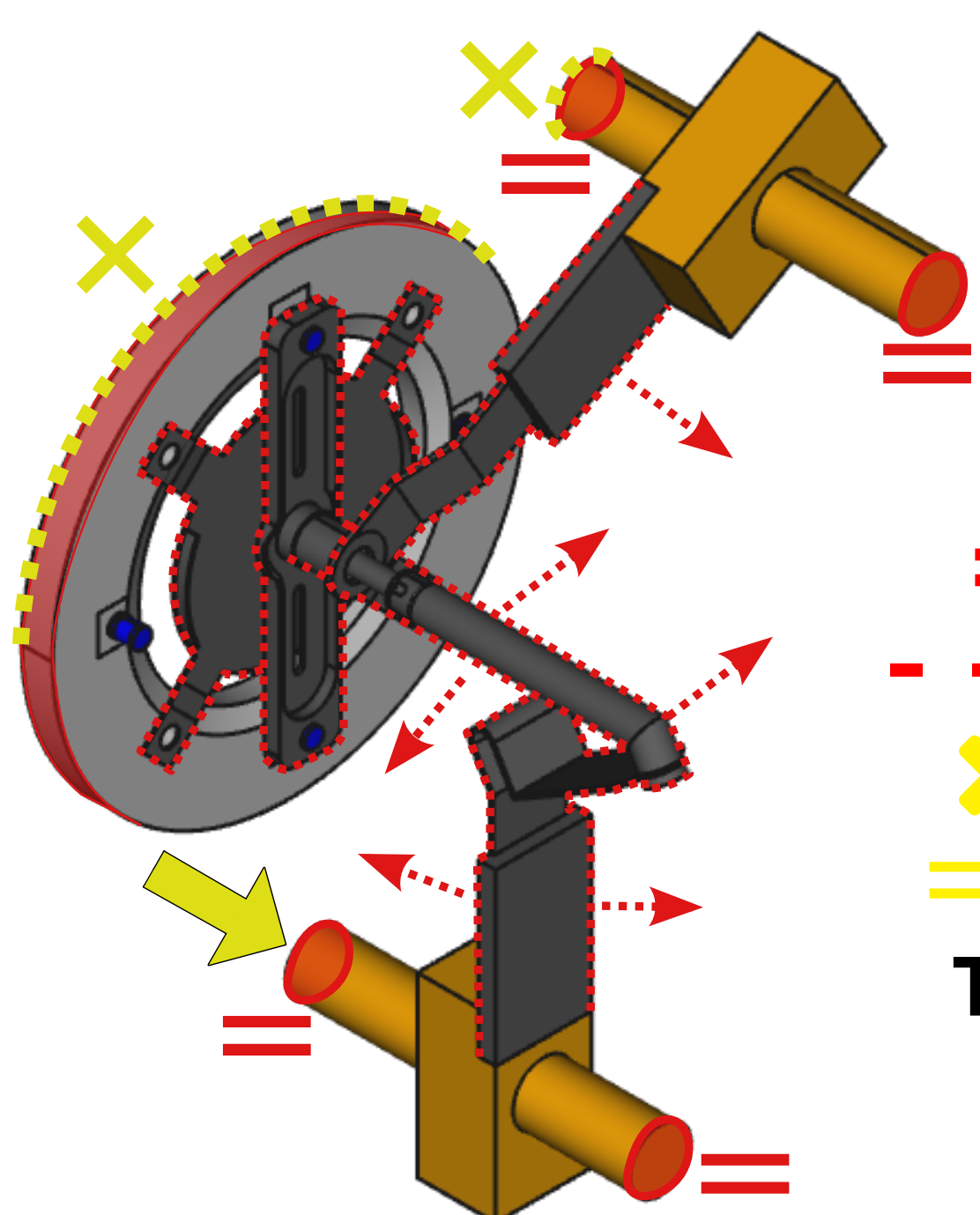


How an adapted ion source can be build to ISOL@MYRRHA conditions?

Improve the cavity temperature profile at higher atom influx with:

- Similar or higher total efficiency
- Higher output intensity, beam quality.
- A robust design

Simulation Setup



3D-Model & ANSYS thermal-electric simulation
 [1] validation with existing data: coming from a study [2] from the SPES project.



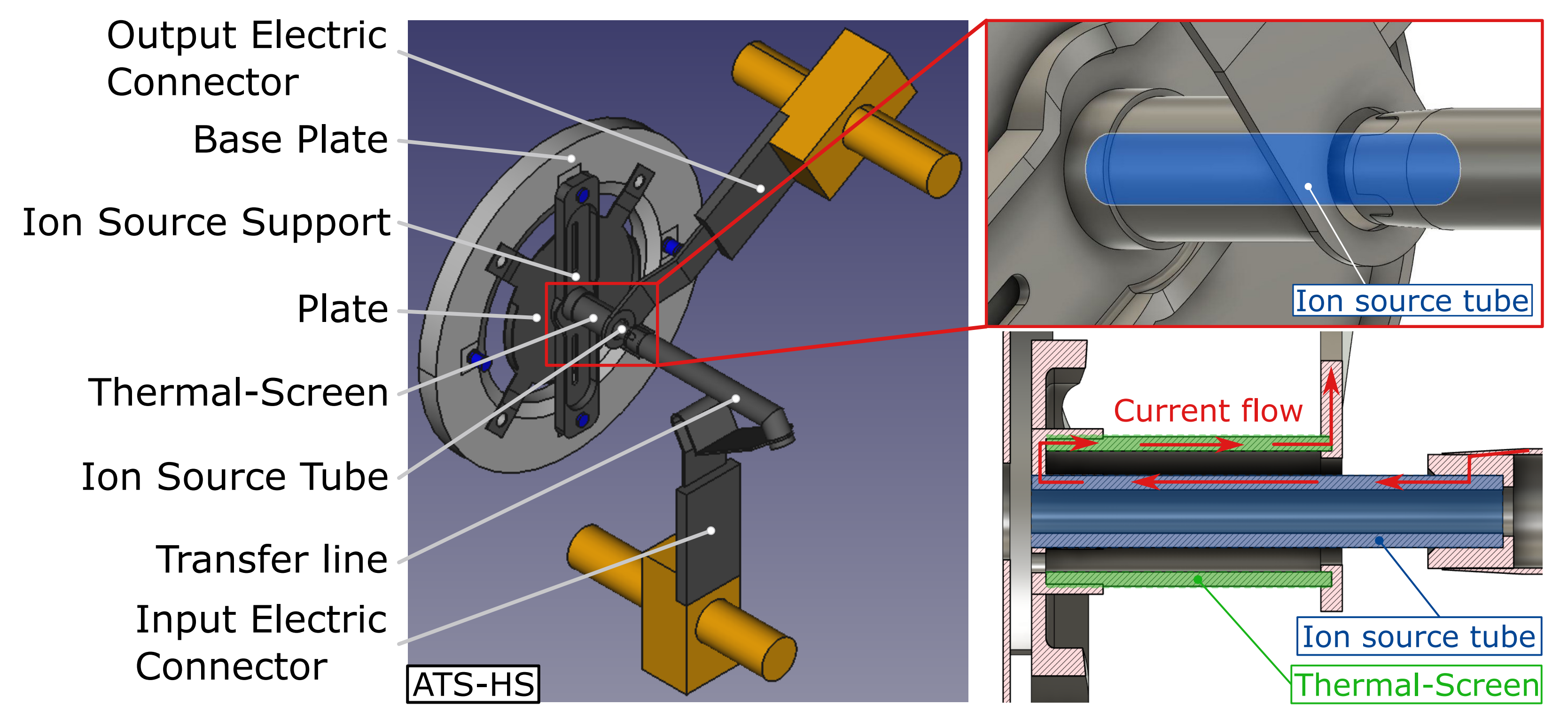
ANSYS boundary conditions:

- Temperature $T_{constr} = 25^{\circ}\text{C}$,
- Radiation emissivity $\epsilon_{Ta}(T^{\circ})$ of tantalum,
- Voltage constraint at 0 V,
- Current load at 380, 350, 300 & 250 A,
- Material High work function ($\phi=4.19 \text{ eV}$), High melting point ($\sim 3000 \text{ }^{\circ}\text{C}$).

References

- [1] ANSYS. <www.ansys.com>.
- [2] M. Manziolo et al. In: *Rev. Sci. Instrum.* 88, 093302 (Sept. 2017). <doi.org/10.1063/1.4998246>.
- [3] Starfish. <www.particleinell.com/starfish>.

New ion Source Design



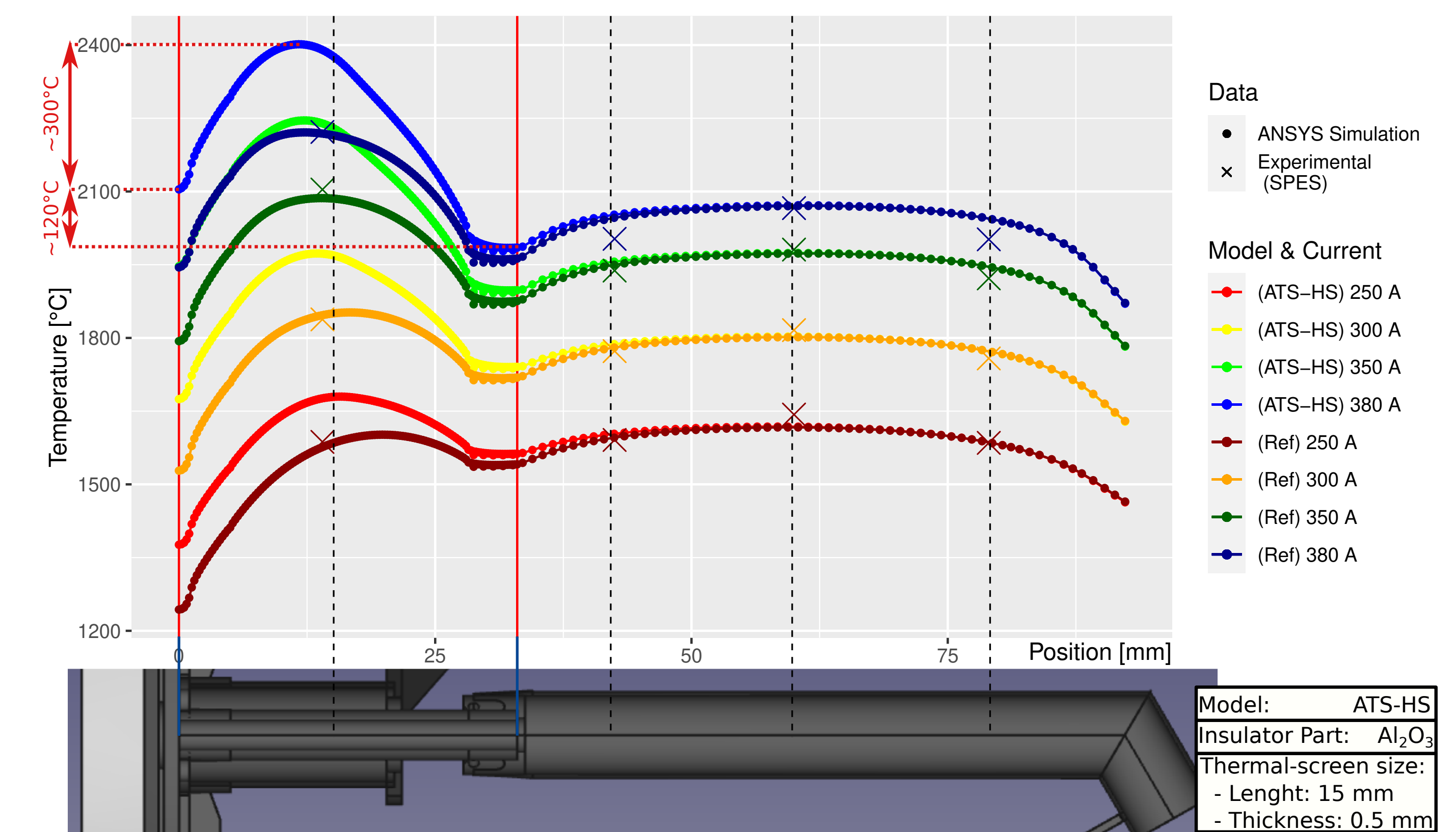
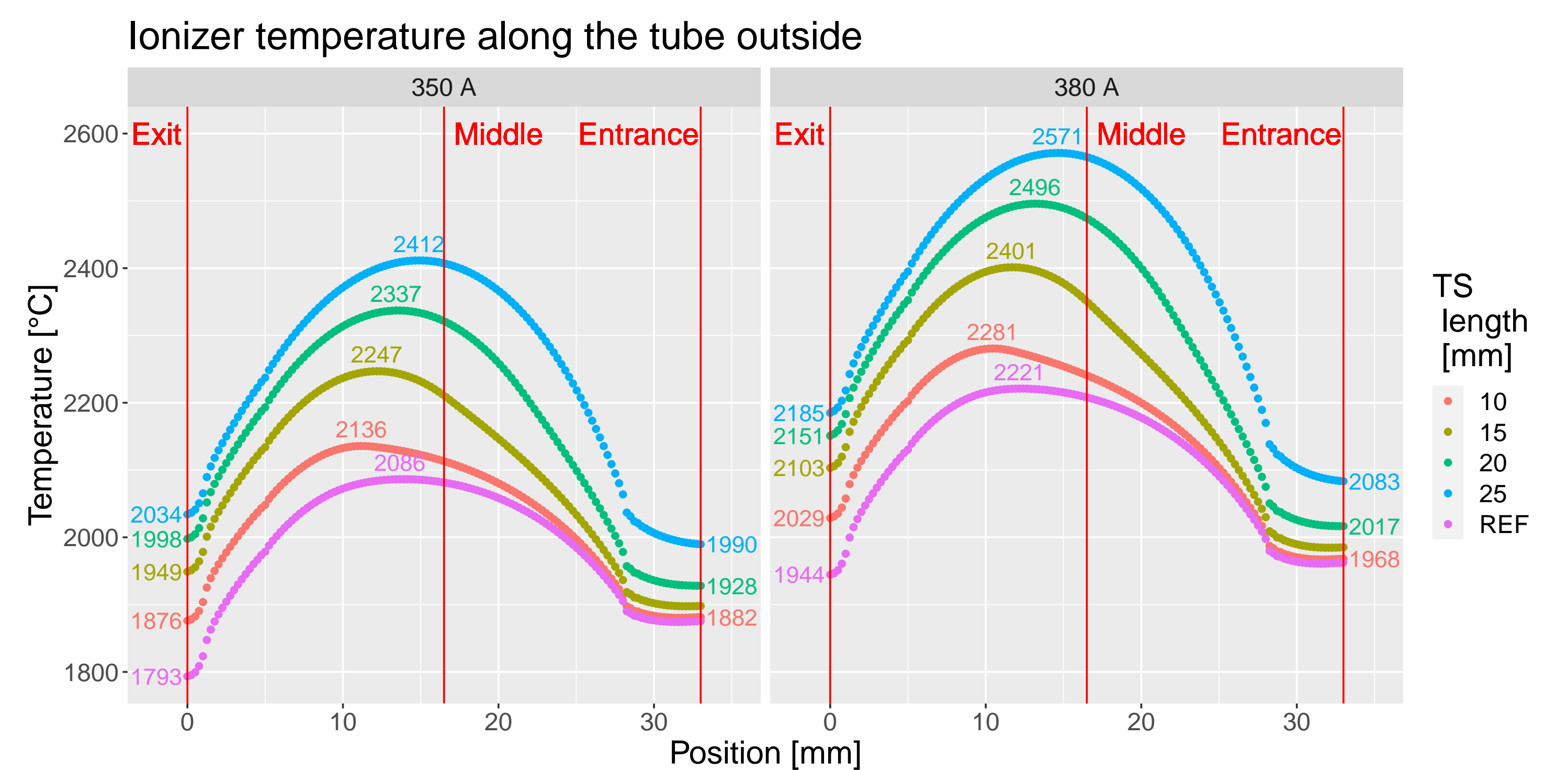
⚡ Add a second feedthrough for the heating system electrical current : one input & one output.

Improve surface ion source heating:

⚡ Insulate electrically (& Thermally) the heating system from its base plate with washer & with a 45° rotation of the plate

↔ Transform a passive thermal-screen into an active part

Thermal-screen Impact



To do Next

An ion source with a higher temperatures at its output was designed, the next steps are to:

- ⚙ Add alignment system similar to SPES SIS to avoid the source displacement after the material thermal expansion
- 🔧 Manufacture & Construct the different pieces
- 🔬 Test on the SCK CEN Thermal-Test Bench
- ⚙ Estimate & Understand the source physical mechanism with Plasma simulation: Starfish [3], an ElectroStatic Particle-in-Cell (ES-PIC) 2D code

